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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Complete if Known

Application Number	Not assigned 10/523487
Filing Date	Herewith
First Named Inventor	Wolfgang Clemens
Group Art Unit	Not assigned 3709
Examiner Name	Not assigned WERT
Attorney Docket Number	411000-124

Sheet 1 Of 1

U.S. PATENT DOCUMENTS

Examiner Initial*	Cite No. ¹	Document Number ----- Number-Kind Code ² (if known)	Publication- Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Examiner Initial*	Cite No. ¹	Foreign Patent Document ----- Country Code ³ Number ⁴ Kind Code ⁵ (if known)	Publication- Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
/J.W./		International Search Report	10/15/2003			

Examiner Signature	/Joshua Wert/ (03/28/2007)	Date Considered	03/28/2007
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Application Number	10/523,487
Filing Date	February 4, 2005
First Named Inventor	Wolfgang Clemens
Group Art Unit	Not assigned 3709
Examiner Name	Not assigned WERT
Attorney Docket Number	411000-124

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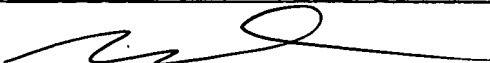
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Examiner Signature	/Joshua Wert/ (03/28/2007)	Date Considered	03/28/2007
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				Application Number	10/523,487
				Filing Date	February 4, 2005
				First Named Inventor	Wolfgang Clemens
				Group Art Unit	Not assigned 3709
				Examiner Name	Not assigned WERT
Sheet	1	Of	1	Attorney Docket Number	411000-124

U.S. PATENT DOCUMENTS

Examiner Initial*	Cite No. ¹	Document Number Number-Kld Code ² (if known)	Publication- Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
J.W./	1	US-6,852,583	10/09/2003	Adolf Bernds et al.	See Disclosure Statement filed herewith
	2	US-10/344,951	N/A	Adolf Bernds et al.	
	3	US-10/382,932	10/02/2003	Adolf Bernds et al.	
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	19	US-10/517,750	N/A	Wolfgang Clemens et al.	
	20	US-10/523,216	N/A	Adolf Bernds et al.	
	21	US-10/523,487	N/A	Wolfgang Clemens et al.	
	22	US-10/524,646	N/A	Walter Fix et al.	
	23	Unknown	N/A	Wolfgang Clemens et al.	
Examiner Signature		/Joshua Wert/ (03/28/2007)		Date Considered	03/28/2007

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Sheet	2	Of	5	Attorney Docket Number	411000.124

J.W.I.		US-5,973,598	10-26-1999	Beigel	
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Examiner Name	Not Assigned WERT				
Sheet	3	Of	5	Attorney Docket Number	411000.124

/J.W./		JP 61167854	07-29-1986	Murata Mfg. Co. Ltd.		X
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Sheet	4	Of	5	Attorney Docket Number	411000.124

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				First Named Inventor	Wolfgang Clemens
				Group Art Unit	Not Assigned 3709
				Examiner Name	Not Assigned WERT
Sheet	5	Of	5	Attorney Docket Number	411000.124

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	131	10/535,448	N/A	Wolfgang Clemens et al.	
	132	10/535,449	N/A	Walter Fix et al.	
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/J.W./		US-2002/0018911	02-00-2002	Bernius et al.	For all references see attached IDS Letter
/J.W./		US-4,926,052	05-15-1990	Hatayama	
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		WO 02/05360 (abstract)	01-17-2002	Siemens AK		X
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				Application Number	10/523,487
				Filing Date	February 4, 2005
				First Named Inventor	Wolfgang Clemens
				Group Art Unit	Not Assigned 3709
				Examiner Name	Not Assigned WERT
Sheet	2	of	2	Attorney Docket Number	411000-124

/J.W./		DAI, L. et al., "I ₂ -Doping" of 1,4-Polydienes", Elsevier Science S.A., Synthetic Metals 69 (1995), pp 563-566.	X
/J.W./		KAWASE, T. et al., "Inkjet Printed Via-Hole Interconnections and Resistors for All-Polymer Transistor Circuits", Advanced Materials 2001, 13, No. 21, November 2, 2001, pp 1601 – 1605.	X
/J.W./		QIAO, X. et al., "The FeCl ₃ -doped poly3-alkithiophenes) in solid state", Elsevier Science, Synthetic Metals 122 (2001) pp 449–454.	X
Examiner Signature		/Joshua Wert/ (03/28/2007)	Date Considered 03/28/2007

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.

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